



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuyoshi TAMURA et al.

Group Art Unit: 1765

Application No.: 09/696,955

Examiner: M. A. Anderson

Filed: October 27, 2000

Docket No.: 107703

For: SILICON FOCUS RING AND METHOD FOR PRODUCING THE SAME

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the September 30, 2003 Office Action, and further to the August 12, 2003 personal interview between Applicants' representative and Examiner Anderson, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims; and

**Remarks.**